



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Naoki KIDANI et al

Group Art Unit: 1755

Serial No.: 10/540,014

Examiner: K. Group

Filed: June 22, 2005

For: LOW TEMPERATURE SINTERING CERAMIC COMPOSITION FOR USE IN HIGH FREQUENCY, METHOD OF FABRICATING THE SAME AND ELECTRONIC COMPONENT

**REQUEST FOR RECONSIDERATION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Dear Sir:

In response to the Office Action of November 13, 2006, the period for response being extended by the concurrently filed petition and fee therefor, Applicants respectfully request reconsideration.

Applicants provide herewith a verified English-language translation of the Japanese priority document. The present claims are supported therein as follows:

Claim No.	Location of Support in Priority Document
1	Claim 1
2	Page 8, second full paragraph
3	Claim 2
4	Page 9, third full paragraph
5	Claim 3
6	Page 4, second full paragraph
7	Page 12, first full paragraph
8	Claim 4